DUSSN 09/896,955

1760

2 3 200 IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appleant (s): Steven M. George et al.

MARSHIAI No.: 09/896,955

Group Art Unit: 1762

FEB 2 5 2004

Filed: June 29, 2001

Examiner: Meeks

For: METHOD FOR FORMING SiO2 BY CHEMICAL VAPOR DEPOSITION AT ROOM

TEMPERATURE

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING SENT
BY FIRST CLASS MAIL ON FABRUARY IA 2004

DATE OF PEPOSIT

GRAPY C. Cohn

PRINT OR TYPE NAME OF PERSON SIGNING CERTIFICATE

SIGNATURE OF PERSONS ENLING CERTIFICATE

Hon. Commissioner of Patents & Trademarks Washington, D.C. 20231

Sir:

RESUBMISSION OF RESPONSE

On January 6, 2004, the undersigned submitted a response, petition for extension of time, fee sheet and credit card authorization form to the USPTO by facsimile to telephone number 703-872-9306. Our facsimile machine printed a conformation report, indicating that the entire 9 pages of the facsimile were successfully sent to a fax machine that identified itself as "USPTO". However, no facsimile auto-transmission was received from the USPTO in response to the fax.

On February 17, Examiner Meeks of Art Unit 1762 called to inquire whether a response had been filed. Examiner Meeks informed us that the facsimile transmission had not been recorded by the USPTO.

Examiner Meeks suggested that we refile the response of January 6, 2004, without payment of additional fees.

Therefore, this paper is being filed to resubmit the papers that were filed on January 6.

Enclosed with this paper are:

UTC 005